



PATENT APPLICATION
Sheet 1 of 1

FORM PTO-1449

**LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION DISCLOSURE
STATEMENT**

(Use several sheets if necessary)

ATTY. DOCKET NO.

10031180-1

SERIAL NO.

10/692,772

APPLICANT

Laura Wills Mirkarimi et al.

FILING DATE

Oct. 24, 2003

GROUP

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	*	DOCUMENT NUMBER	DATE	NAME
	i			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	NAME	TRANSLATION	
					YES	NO

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

LV		Grover, Rohit, "Process Development of Methane-Hydrogen-Argon-Based Deep Dry Etching of InP High Aspect-Ratio Structures with Vertical Facet-Quality Sidewalls", Journal of Vacuum Science Technology, B 19(5), Se/Oct 2001, pp. 1694-1698.

EXAMINER

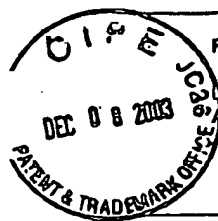
LAN VINH

DATE CONSIDERED

5/31/05

*Copies of the references are not enclosed pursuant to 37 CFR 1.98(d). (See accompanying IDS)

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EXAMINER INITIAL	*	DOCUMENT NUMBER	DATE	NAME
LV		5,624,529	04/29/97	Randy J. Shul et al.
LV		5,338,394	08/16/94	Mohammed A. Fathimulla et al.

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	NAME	TRANSLATION	
					YES	NO

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

LV		Chen, Hsin-Yi et al., "Inductively Coupled Plasma Etching of InP using CH ₄ /H ₂ and CH ₄ /H ₂ /N ₂ ", Journal of Vacuum Science Technology, B 20(1), Jan/Feb 2002, pp. 47-52.
LV		Hur, Katerina Y., et al., "Reactive Ion Etching of InP Via Holes", Journal of Vacuum Science Technology, B 12(3), May/Jun 1994, pp. 1410-1412.
LV		Feupier, Y. et al., "Influence of the Gas Mixture on the Reactive Ion Etching of InP in CH ₄ -H ₂ Plasmas, Journal of Vacuum Science Technology, B 15(5), Sep/Oct 1997, pp. 1733-1740.

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